

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> <small>(Use several sheets if necessary)</small>			Attorney Docket No.: <b>8017-1106</b>		Application No.: <b>10/698,377</b> <b>NEW NONPROVISIONAL</b>			
			Applicant: <b>Shuichi NAKANISHI et al.</b>		Filing Date: <b>November 3, 2003</b>		Group Art Unit: <b>285</b>	
<b>U.S. PATENT DOCUMENTS</b>								
Examiner Initial	Document Number	Date	Name		Class	Subclass		
(List U.S. Patent Documents)								
<b>FOREIGN PATENT DOCUMENTS</b>								
Examiner Initial	Document Number	Date	Country		Class	Subclass	Translation	
							Yes	No
R.B.	JP 2002-244211	8/30/2002	JAPAN		—	—	abst only	
R.B.	JP 2001-174775	6/29/2001	JAPAN		—	—		
R.B.	JP 11-331879	11/30/1999	JAPAN		—	—		
R.B.	JP 9-138371	5/27/1997	JAPAN		—	—		
R.B.	JP 2999952	11/5/1999	JAPAN		—	—		
R.B.	JP 11-281931	10/15/1999	JAPAN		—	—		
R.B.	JP 5-257110	10/8/1993	JAPAN		—	—		
R.B.	JP 6-289387	10/18/1994	JAPAN		—	—		
R.B.	JP 7-140415	6/2/1995	JAPAN		—	—		
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
EXAMINER:			DATE CONSIDERED				10/20/04	
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\* Abstract provided for the Examiner's convenience